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EXAMINER

BURLESON, MICHAEL L

ART UNIT PAPER NUMBER

2625

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Please find below and/or attached an Office communication concerning this application or proceeding.

Office Action Summary

Application No.

09/783,323

Applicant(s)

SAWADA ET AL.

Examiner

Michael Burleson

Art Unit

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-- The MAILING DATE of this communication appears on the cover sheet with the correspondence address --

Period for Reply

A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) OR THIRTY (30) DAYS, WHICHEVER IS LONGER, FROM THE MAILING DATE OF THIS COMMUNICATION.

- Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication.
- If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication.
- Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133). Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).

Status

- 1) ☒ Responsive to communication(s) filed on 26 January 2006.
- 2a) ☐ This action is **FINAL**. 2b) ☒ This action is non-final.
- 3) ☐ Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under *Ex parte Quayle*, 1935 C.D. 11, 453 O.G. 213.

Disposition of Claims

- 4) ☒ Claim(s) 1-15 is/are pending in the application.
- 4a) Of the above claim(s) _____ is/are withdrawn from consideration.
- 5) ☐ Claim(s) _____ is/are allowed.
- 6) ☒ Claim(s) 1-15 is/are rejected.
- 7) ☐ Claim(s) _____ is/are objected to.
- 8) ☐ Claim(s) _____ are subject to restriction and/or election requirement.

Application Papers

- 9) ☐ The specification is objected to by the Examiner.
- 10) ☐ The drawing(s) filed on _____ is/are: a) ☐ accepted or b) ☐ objected to by the Examiner.
- Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).
- Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).
- 11) ☐ The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.

Priority under 35 U.S.C. § 119

- 12) ☐ Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).
- a) ☐ All b) ☐ Some * c) ☐ None of:
1. ☐ Certified copies of the priority documents have been received.
 2. ☐ Certified copies of the priority documents have been received in Application No. _____.
 3. ☐ Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)).

* See the attached detailed Office action for a list of the certified copies not received.

Attachment(s)

- | | |
|--|---|
| 1) <input checked="" type="checkbox"/> Notice of References Cited (PTO-892) | 4) <input type="checkbox"/> Interview Summary (PTO-413)
Paper No(s)/Mail Date. _____ |
| 2) <input type="checkbox"/> Notice of Draftsperson's Patent Drawing Review (PTO-948) | 5) <input type="checkbox"/> Notice of Informal Patent Application (PTO-152) |
| 3) <input type="checkbox"/> Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08)
Paper No(s)/Mail Date _____ | 6) <input type="checkbox"/> Other: _____ |

Response to Arguments

1. Applicant's arguments, see remarks page 2-3, filed 01/25/2006, with respect to the rejection(s) of claim(s) 1-3,5 have been fully considered and are persuasive.

Therefore, the rejection has been withdrawn. However, upon further consideration, a new ground(s) of rejection is made in view of Haneda US 6011575. Regarding claims 4,6-15, upon further consideration, allowability has been withdrawn and these claims are now rejected under Haneda US 6011575.

Claim Rejections - 35 USC § 112

1. The following is a quotation of the second paragraph of 35 U.S.C. 112:

The specification shall conclude with one or more claims particularly pointing out and distinctly claiming the subject matter which the applicant regards as his invention.

2. Claim 14 is rejected under 35 U.S.C. 112, second paragraph, as being indefinite for failing to particularly point out and distinctly claim the subject matter which applicant regards as the invention.

3. Regarding claim 14, Examiner fails to understand how the resist pattern forming device forms resist patterns on the transfer body of claim 14, but is claimed to form resist patterns on recording medium of claim 10 from which claim 14 depends upon.

Claim Rejections - 35 USC § 102

(e) the invention was described in (1) an application for patent, published under section 122(b), by another filed in the United States before the invention by the applicant for patent or (2) a patent granted on an application for patent by another filed in the United States before the invention by the applicant for patent, except that an international application filed under the treaty defined in section 351(a) shall have the effects for purposes of this subsection of an application filed in the United States only if the international application designated the United States and was published under Article 21(2) of such treaty in the English language.

1. Claims 1-15 are rejected under 35 U.S.C. 102(e) as being anticipated by Haneda US 6011575.
2. Regarding claim 1, Haneda teaches of an exposure optical system (12) composed of an LED array arranged in the axis direction of photoreceptor drum (10) (column 4, lines 1-7), which reads on an image forming apparatus comprising: an exposure unit which exposes an image carrier by emitting light of light emitting elements based on image data. Haneda teaches of a registration sensing means (RS) (column 9, lines 10-15, 18-35 and 52-56), which reads on an input device for inputting distortion data of the exposure unit. Haneda teaches of a control section (251) (column 9, lines 52-56 and 14-25 and column 10, lines 20-25), which reads on a controller, which controls an exposure position of an image to be exposed by the exposure unit, based on the input distortion data.
3. Regarding claim 2, Haneda teaches of an exposure optical system (12) composed of an LED array arranged in the axis direction of photoreceptor drum (10) (column 7, lines 65-67), which reads on the exposure unit includes a plurality of the light emitting elements that are arranged in a line.

4. Regarding claim 3, Haneda teaches that the LED array provides image exposure (column 7, lines 29-32), which reads on data corresponding to each of the light emitting elements are input.

5. Regarding claim 4, Haneda teaches of image information being inputted from outside the apparatus (column 6, lines 21-24), which reads on the input device is an operation panel operated by the user.

6. Regarding claim 5, Haneda teaches that the registration sensing means (RS) consists of image sensor (RS1), image forming lens (RS2) and LED (RS3) (column 9, lines 25-35), which reads on the input device is equipped with plural kinds of input methods.

7. Regarding claim 6, Haneda teaches of an exposure optical system (12) composed of an LED array arranged in the axis direction of photoreceptor drum (10) (column 4, lines 1-7), which reads on an image forming apparatus comprising: an exposure unit which exposes an image carrier by emitting light of light emitting elements based on image data. Haneda teaches of a transfer device (14A) (column 5, lines 33-37), which reads on a transfer unit which transfers a latent image created on said image carrier as a revealed image onto a transfer body. Haneda teaches of a registration sensing means (RS) (column 9, lines 10-15, 18-35 and 52-56), which reads on an input device for inputting distortion data of the exposure unit. Haneda teaches that image sensor (RS1) and light emitting element (RS3) sense registration patterns (column 9, lines 34-43), which reads on at least two optical sensors which read out resist patterns formed on said transfer body. Haneda teaches of a control section (251) (column

8,lines 35-58, column 9,lines 52-56 and 14-25 and column 10,lines 15-25 and 20-25), which reads on a data processor which forms skew correction data based on a relative deviation amount in main and sub scanning directions of the exposure unit, that is obtained by a readout of the resist patterns by the optical sensors and a controller which controls an exposure position of an image to be exposed by the exposure unit, based on the input device and skew correction data.

8. Regarding claim 7, Haneda teaches of an exposure optical system (12) composed of an LED array arranged in the axis direction of photoreceptor drum (10) (column 7,lines 65-67), which reads on the exposure unit includes a plurality of the light emitting elements that are arranged in a line.

9. Regarding claim 8, Haneda teaches that the LED array provides image exposure (column 7,lines 29-32), which reads on data corresponding to each of the light emitting elements are input.

10. Regarding claim 9, Haneda teaches that the registration sensing means (RS) is arranged at a predetermined distance in the main-scanning direction from a center position (figure 3), which reads on each of the optical sensors is arranged in a position at a predetermined distance in the main-scanning direction from a center position of the arrangement of the light emitting elements.

11. Regarding claim 10, Haneda teaches of an exposure optical system (12) composed of an LED array arranged in the axis direction of photoreceptor drum (10) onto recording paper (column 4,lines 1-7 and column 5,lines 3-45), which reads on an image forming apparatus comprising: an exposure unit which exposes an recording

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medium by emitting light of light emitting elements based on image data, thereby forming an image. Haneda teaches of RAM (253) (column 10, lines 15-18), which reads on a memory device, which stores distortion data of the exposure unit. Haneda teaches of a registration sensing means (RS) (column 9, lines 18-21), which reads on a resist pattern forming device which forms resist patterns on the recording medium. Haneda teaches that image sensor (RS1) and light emitting element (RS3) sense registration patterns (column 9, lines 34-43), which reads on sensors which read out resist patterns formed on said transfer body. Haneda teaches of a control section (251) (column 9, lines 52-56 and 14-25 and column 10, lines 15-25 and 20-25), which reads on a controller which determines recording positional deviation data of the exposure unit based on the read-out result of the resist patterns by the sensors, and controls exposure positions of the image to be exposed by the exposure unit based on the recording positional deviation data and distortion data.

12. Regarding claim 11, Haneda teaches of an exposure optical system (12) composed of an LED array arranged in the axis direction of photoreceptor drum (10) (column 7, lines 65-67), which reads on the exposure unit includes a plurality of the light emitting elements that are arranged in a line.

13. Regarding claim 12, Haneda teaches that the LED array provides image exposure (column 7, lines 29-32), which reads on data corresponding to each of the light emitting elements are input.

14. Regarding claim 13, Haneda teaches that the registration sensing means (RS) is arranged at a predetermined distance in the main-scanning direction from a center

position (figure 3), which reads on each of the optical sensors is arranged in a position at a predetermined distance in the main-scanning direction from a center position of the arrangement of the light emitting elements.

15. Regarding claim 14, Haneda teaches of exposure units 12C, 12M, 12Y, 12K (figure 3), which reads on wherein a plurality of the exposure units are provided for forming color images. Haneda teaches of storing an image in memory (column 4, lines 29-33), which reads on wherein an image storage device for storing image data is further provided. Haneda teaches linearity is corrected and then registration patterns are formed on the photoreceptor drum (10) by the registration sensing means (RS), which is taken from ROM (252) (column 8, lines 59-67 – column 9, lines 1-67), which reads on wherein the controller corrects linear distortion of the exposure units, using distortion data input from the input device, and then forms the resist patterns on the transfer body by means of the resist pattern forming device, to thereby relatively detect the positional deviation of the images in the exposure units with respect to the image in the reference exposure units with respect to the image in the reference exposure unit by means of the optical sensor device, and execute address control of the image storage device so as to correct the positional deviation of the images based on the detected result.

16. Regarding claim 15, Haneda teaches of correcting positional deviation of images (column 10, lines 2-25), which reads on wherein the controller corrects linear distortion of the exposure units, and thereafter corrects the positional deviation of the images.

Conclusion

Any inquiry concerning this communication should be directed to Michael Burleson whose telephone number is (571) 272-7460 and fax number is (571) 273-7460. The examiner can normally be reached Monday thru Friday from 8:00 a.m. – 4:30p.m. If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Kimberly Williams can be reached at (571) 272-7471

Michael Burleson
Patent Examiner
Art Unit 2626

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KIMBERLY WILLIAMS
SUPERVISORY PATENT EXAMINER

Mlb
June 06, 2006